

## A METHOD OF MEASURING SMALL PADS ON A SUBSTRATE

Milad F. Tabet

### ABSTRACT

5 A method of measuring a small area on a substrate with an ellipsometer,  
comprising orienting a substrate with respect to the ellipsometer such that an elliptical  
light spot produced by the ellipsometer fits diagonally within the test area. Then  
measuring the surface properties of the substrate within the test area with the  
ellipsometer.